## **AMENDMENTS TO THE CLAIMS**

1. (currently amended) A method of connecting an electronic part, comprising:
forming an electroless nickel plating coat containing phosphorous on a pad having a size
of 300 μm or less in diameter and comprising Ni crystals that have a half-width of X-ray
diffraction of a (111) plane in a range of 4 degrees to 2 degrees, on a substrate metal layer which
constitutes a connecting terminal of an electronic part; and

carrying out <u>binding connecting</u> to the nickel plating coat through a lead-free solder, wherein a half-width of X-ray diffraction of a (111) plane of Ni crystal in the nickel plating coat is 5 degrees or less.

- 2. (original) The connecting method according to Claim 1, wherein the plating coat is formed using an electroless nickel plating solution containing 5.5 mass% or less of phosphorous.
- 3. (original) The connecting method according to Claim 1, wherein the plating coat is formed using an electroless nickel plating solution containing 4.5 mass% or less of phosphorous.
  - 4. (cancelled).
  - 5. (cancelled).
- 6. (original) The connecting method according to Claim 1, wherein annealing is carried out at a temperature of 250°C to 400°C, after the electroless nickel plating coat is formed.

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